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# Development and implementation of an optical profilometer by laser triangulation

[Desarrollo e implementación de un perfilómetro óptico por triangulación láser]

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**Abstract**

Profilmeters are instruments commonly used in surface metrology tasks. These instruments play a key role in the industry, such as in manufacturing and quality assurance. However, conventional profilometry techniques require direct contact with the object. In this work, we developed a practical and low-cost optical profilometer for contactless profilometry. The proposed profilometer is based on a